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U.S. Department of Commerce Patent and Trademark Office

Attorney's Docket No. 12852-020001

Application No. 10/664,690

Information Disclosure Statement by Applicant (Use several sheets if necessary)

Applicant Hiromi Nakanishi et al.

Filing Date

Group Art Unit

(37 CFR §1.98(b))

September 18, 2003

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
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Foreign Patent Documents or Published Foreign Patent Applications								
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